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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Applicant:

Tsuga et al.

Art Unit:

1746

Serial No.:

10/085,725

Examiner:

Kornakov, M.

Filing Date:

02/28/2002

Docket No.:

TI-31621

Customer No.: 23494

Conf. No.:

1672

Title:

METHOD AND DEVICE FOR REMOVING PARTICLES ON

SEMICONDUCTOR WAFERS

AMENDMENT UNDER 37 CFR 1.111

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark Office at (703) 872 - 9306 on 6/21/2004.

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Jacqueline J. Garner No: 36,144

Dear Sir:

The following amendments and remarks are offered in response to the Examiner's Office Action dated 01/20/2004. They are respectfully submitted as a full and complete response to that Action.

Please amend the above-referenced application as follows:

There are no Amendments to the Specification.

Amendments to the Claims are reflected in the listing of claims that begin on page 2 of this paper.

There are no Amendments to the Drawings.

The Remarks begin on page 3.